

	Diameter of test particles			
	1.51 nm (Fig. 4a)	2.41 nm (Fig. 4a)	3.93 nm (Fig. 4a)	1.51, 2.41, and 3.93 nm (Fig. 4d)
Electrometer	5540	3097	7081	8637
EM algorithm	5528	3243	20.5	8546
H&A method	5426	3027	0	8050
Kernel function method	7562	3497	227	10 948
Stepwise method	5910	3179	1591	12 035